

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: : Atty Docket: 02-GR1-410  
Thierry PARRASSIN : APPLICATIONS BRANCH  
Serial No. (not yet assigned) :  
Filed: HEREWITH :

For: *FOCUSED ION BEAM TREATMENT METHOD AND SEMICONDUCTOR  
DEVICE SUITABLE FOR ITS IMPLEMENTATION*

**CERTIFICATE OF EXPRESS MAIL MAILING**

"Express Mail" Mailing Label No. **EV381145774US**  
Date of Deposit: **February 19, 2004**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

I hereby certify that

☒ Application Transmittal  
☒ Fee Transmittal Form  
☒ Specification, Claims, Abstract  
☒ 1 set of 3 sheets of drawings  
☒ Unexecuted Declaration and Power of Attorney  
☒ Return postcard

are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to:

MS Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

2/19/04  
Date of Deposit

Kathleen Schlosbon  
Name of person mailing papers

Kathleen Schlosbon  
Signature

22859 U.S. PTO  
10/782724



10/152 U.S. PTO

EXPRESS MAIL LABEL NO. EV381145774US

DOCKET NO. 02-GR1-410

## UTILITY PATENT APPLICATION TRANSMITTAL

ADDRESS TO: Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Transmitted herewith for filing is the patent application of:

INVENTOR: Thierry PARRASSIN

TITLE: *FOCUSED ION BEAM TREATMENT METHOD AND SEMICONDUCTOR  
DEVICE SUITABLE FOR ITS IMPLEMENTATION*

## ASSIGNEE INFORMATION PURSUANT TO 37 C.F.R. 1.76

ASSIGNEE NAME: STMICROELECTRONICS SA  
ASSIGNEE RESIDENCE: MONTRouGE, FRANCE

In connection with this application, the following are enclosed:

XX Fee Transmittal Form  
17 Pages of Specification, Claims and Abstract  
17 Claims  
3 Sheets of Drawings (FIGS. 1-6)  
XX Unexecuted Declaration and Power of Attorney

Please direct all correspondence to **Customer Number 23334**.

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Respectfully submitted,

By: 

Stephen Bongini  
Reg. No. 40,917

EXPRESS MAIL LABEL NO. EV381145774US

DOCKET NO. 02-GR1-410

## FEE TRANSMITTAL

Transmitted herewith for filing is the patent application of:

INVENTOR: Thierry PARRASSIN

TITLE: FOCUSED ION BEAM TREATMENT METHOD AND SEMICONDUCTOR  
DEVICE SUITABLE FOR ITS IMPLEMENTATION

The fee has been calculated as shown below. (Small entity fees indicated in parentheses.)


For	Number Filed		Number Extra	Rate Large (Small)	Basic Fee \$770 (\$385)
Total Claims	17	20	0	\$18 (\$9)	0
Independent Claims	2	3	0	\$86 (\$43)	0
Multiple Dependent Claims				\$290 (\$145)	0
Assignment Recording Fee				\$40	0
TOTAL FEE:				\$	770

\_\_\_\_ The Commissioner is hereby authorized to charge Deposit Account No. \_\_\_\_\_ in the amount of \$\_\_\_\_\_.

\_\_\_\_ The Commissioner is hereby authorized to charge payments of (1) any additional filing fees required under 37 CFR 1.16, and/or (2) any patent application processing fees under 37 CFR 1.17 associated with this application or credit any overpayment to Deposit Account No. \_\_\_\_\_.

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